

APPLICANT'S ART CITATION Use several sheets if necessary)		Application 10/633,833		OFGS File No. P/2291-110			
		Applicant Etsuro ENDO					
		Filing Date August 4, 2003		Group Art Unit --			
U.S. PATENT DOCUMENTS (copies not submitted)							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class		
AR	US-2003/0003973 A1	01-2003	Zhou, et. al.				
	US-						
	US-						
	US-						
	US-						
	US-						
	US-						
	US-						
FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
AR	WO 02/35736 A1	05-2002	PCT			Abstract	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
AR		Examination Report issued by English Patent Office in connection with corresponding					
↓		Great Britain application no. GB0318338.1 on February 27, 2006					
Examiner /Alejandro Rivero/		Date Considered 07/18/2006					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							



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	US-					
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	US-					
	US-					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
AR	2000-228647	08-2000	Japan				X
AR	CN 1294334 A	05-2001	China				X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AR		Office Action issued by Chinese Patent Office in connection with corresponding Chinese application no. 200410080454.0 on December 30, 2005
		English translation of Office Action issued by Chinese Patent Office on December 30, 2005
↓		in connection with corresponding Chinese application no. 200410080454.0

Examiner /Alejandro Rivero/ Date Considered 07/18/2006

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